

Docket No.: 061282-0055

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Takeshi KOBAYASHI, et al. : Confirmation Number: 4950
Application No.: 10/757,388 : Group Art Unit: 2814
Filed: January 15, 2004 : Examiner: Dilinh P. Nguyen
:

For: LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR DEVICE USING LEAD FRAME AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

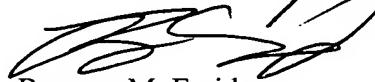
Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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**Please recognize our Customer No. 20277
as our correspondence address.**



SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 061282-0055	SERIAL NO. 10/757,388	
APPLICANT Takeshi KOBAYASHI, et al.						
				FILING DATE January 15, 2004	GROUP 2814	
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	US	6,339,261 B1	01/15/2002	Yonemochi et al.		
	US	2002/0027265 A1	03/07/2002	Yoneda et al.		
	US	6,329,711 B1	12/11/2001	Kawahara et al.		
	US					
	US					
	US					
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4 -Kind Codes (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation
		EP 0 977 259 A2	02/02/2000	Fujitsu Limited		X No
		EP 0 999 587 A2	05/10/2000	Shinko Electric Industries Co. Ltd.		X No
		EP 0 645 952 A1	03/29/1995	Rogers Corporation		X No
		JP 11 067838	03/09/1999	Matsushita Electric Industrial Co., Ltd.		English Abstract No
		JP 56 148846	11/18/1981	NEC Corporation		Japan w/ English Abstract No
		JP 06 148661	05/27/1994	Matsushita Electric Industrial Co., Ltd.		Japan w/ English Abstract No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
EXAMINER				DATE CONSIDERED		

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Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.